



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Hyug-Jin Kwon

Serial No.:

10/615,062

Filed:

July 8, 2003

Title:

BATCH TYPE ATOMIC LAYER

DEPOSITION APPARATUS AND IN-SITU CLEANING METHOD THEREOF

Group Art Unit:

1763

Examiner:

Sylvia MacArthur

Attorney Docket No.: 29926/39496

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on October 11, 2005.

Sandip H. Patel (Reg. No. 43,848)

Attorney for Applicant

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

This paper is being timely submitted in response to a notice from the U.S. Patent and Trademark Office dated October 3, 2005, stating that the applicant's paper filed September 19, 2005, was not compliant with 37 CFR § 1.121 because the paper did not include the proper status identifiers for claims 1-7 and 9. In view of the notice, the applicant hereby appends to this paper a recitation of the claims with the proper status identifiers.

No fee is believed to be due.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

October 11, 2005

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